



Attorney Docket No.: 015675.P326

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Andre Leycuras

Serial No.: 09/601,109

Filed: October 16, 2000

For: **CHEMICAL VAPOR DEPOSITION  
REACTOR AND PROCESS**

Examiner: Chen, B.

Art Unit: 1762

#6/8  
Jed  
1/3/01

**AMENDMENT AND RESPONSE TO OFFICE ACTION  
AND PETITION FOR EXTENSION OF TIME**

Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

In accordance with 37 C.F.R. § 1.136(a) and in connection with the Office Action dated June 25, 2001, Applicant for the above-identified application respectfully petitions the Commissioner for a two (2) month extension of time, extending the period for response to Sunday, November 25, 2001. The filing fee for a two month extension of time, large entity, is \$400.00. A check in the amount of \$400.00 is enclosed.

If it should be determined that a longer extension of time is required to prevent this Application from becoming abandoned, or that any additional fees are required for the requested amount of time, please charge any additional fees to Deposit Account No. 02-2666. A duplicate copy of the fee transmittal is enclosed for charging purposes.

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DEC 31 2001  
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